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FEB 28 2005

Patent Application  
ATM-515 (7486)IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: XU, Chongying, et al.

Application No.: 10/015,326

Date Filed: December 13, 2001

Title: METHOD FOR REMOVAL  
OF IMPURITIES IN CYCLIC  
SILOXANES USEFUL AS  
PRECURSORS FOR LOW  
DIELECTRIC CONSTANT  
THIN FILMS

Docket No.: ATMI-515 (7486)

Examiner: Virginia MANOHARAN

Art Group: 1764

Confirm. No.: 2946

Customer No.:

25559

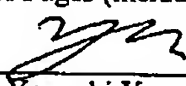
## FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Virginia MANOHARANFax No.: (703) 872-9306

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on February 28, 2005, to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Number of Pages (including cover)

  
Yongzhi Yang

February 28, 2005

Date

RESPONSE TO NOVEMBER 26, 2004 OFFICE ACTION  
IN UNITED STATES PATENT APPLICATION NO. 10/015,326

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the November 26, 2004 Office Action in the above-identified application. Please amend the claims of the application as set out in the following Section I (Amendments to the Claims). Remarks addressing various issues raised in the November 26, 2004 Office Action are set out in Section II (Remarks) hereof.

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